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APPLICANTS

Takaharu Kondo, Kyoto, JAPAN;

Koichi Matsuda, Kyoto, JAPAN;

**** CONTINUING DATA ******* *None*
**** FOREIGN APPLICATIONS *******
 JAPAN 162804/2000 05/31/2000

 IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged <i>alad</i> Examiner's Signature Initials	JAPAN	5	21	5

ADDRESS
 05514
 FITZPATRICK CELLA HARPER & SCINTO
 30 ROCKEFELLER PLAZA
 NEW YORK, NY
 10112

TITLE
 Silicon-type thin-film formation process, silicon-type thin film, and photovoltaic device

FILING FEE RECEIVED 1018	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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